



# ContourGT 3D Optical Microscopes

Unprecedented Resolution

Optical Metrology

Innovation with Integrity

# ContourGT — 30 Years of Non-Contact Surface Metrology Innovation

The ContourGT<sup>®</sup> Family combines advanced 64-bit, multi-core operation and analysis software, patented white light interferometric (WLI) hardware, and unprecedented operator ease-of-use to deliver the most advanced 3D optical surface profilers ever developed. Bruker's tenth-generation surface profilers provide fast, sub-nanometer resolution metrology over large fields of view, with flexible sample setup and industry-leading repeatability. The ContourGT Family is the most comprehensive and intuitive 3D surface metrology platform available today for research, production and quality control applications.

### Unmatched Measurement Capabilities with Best Lateral and Vertical Resolution over Industry's Largest Field of View

- Magnifications from 0.5X to 230X enable characterization of a wide range of surface shapes and textures
- Sub-nanometer to over 10mm vertical range at any magnification delivers unparalleled measurement flexibility
- R&D 100 Award-winning AcuityXR<sup>™</sup> measurement capability provides unmatched lateral resolution

### Robust Metrology Hardware for Enhanced Reliability and Repeatability in Production Environments

- Patented dual-source illumination with super highbrightness LEDs provides superior measurement quality and magnification flexibility
- Optimized hardware improves vibration tolerance and gauge R&R capability
- Patented self-calibration capability on select models ensures tool-to-tool correlation and measurement accuracy and repeatability

### 64-Bit, Multi-Core Processor with Vision64<sup>™</sup> Software for Accelerated 3D Surface Measurement and Analyses

- Advanced architecture yields order of magnitude increase in data processing capacity
- Parallel processing using multi-core optimization and other techniques provides up to 10x higher throughput on critical metrology analyses
- Unmatched stitching capability seamlessly synthesizes thousands of individual datasets into one contiguous image

### Highly Intuitive User Interface with Best-in-Class Ease of Use, Automation, and Analysis

- Streamlined user interface simplifies measurement and data acquisition to increase system and personnel efficiency
- Unique visual workflow provides intuitive access to an extensive library of filters and analysis options
- Customized reporting distills analysis data for customer-specific requirements



### Maximum Surface Capability with Application-Specific Customization

The ContourGT Family features industry-leading measurement scope and flexibility to provide quantified 3D surface characterization for an extremely wide range of surfaces, from rough to smooth, hard to soft, adhesive, deflectable or otherwise difficult to measure. With its uniquely intuitive user interface and extensive automation features, the ContourGT 3D optical microscopes can be tailored to meet the needs of virtually any surface metrology application.

### **Ophthalmic Contact and Intraocular Lenses**

Customized analyses and automation for optics maximize throughput and allow calculation of Zernikes, aspheric coefficients, point-spread function and more.



Stitched measurement of a bifocal contact lens showing form.

### **Micro-Electro Mechanical Systems (MEMS)**

ContourGT measures microfluidics and MEMS devices throughout the manufacturing process, from wafer to final test, even through transparent packaging and during device actuation.



3D investigation of microfluidics features.

### **Precision Machined Components**

ContourGT systems robustly determine surface finish, critical angles, spacing, radii, and other dimensions to improve manufacturing of high-tolerance components.







### **High-Brightness LEDs**

ContourGT provides high-throughput, nondestructive measurements for PSS height, pitch and width, as well as wafer and Epi layer roughness, substrate bow, and film thickness to improve yield and ensure LED efficiency and color consistency.



Topography of features on a patterned sapphire substrate wafer.

### Solar

ContourGT calculates 3D surface texture parameters with proven correlation to photovoltaic efficiency to enhance yield and performance in solar cell manufacturing.



3D characterization of monocrystalline solar cell.

### **Tribology and Corrosion**

ContourGT topographic imaging provides quantitative surface data to facilitate understanding of friction, corrosion and other wear mechanisms for life-cycle and QA/QC.



Wear scar in metal showing minor debris deposition on sidewall.

# **3D Surface Metrology**

### New Benchmark for Operation and Analysis

Today's sophisticated metrology technology requires advanced software that is powerful, user-friendly, and capable of addressing specific measurement requirements. The new Vision64<sup>™</sup> Operation and Analysis Software provides the industry's most functional and streamlined graphical user interface, combining intelligent architecture with intuitive visual workflow and extensive user-defined automation capabilities for fast and comprehensive data collection and analysis.



Vision64 GUI — Unmatched Functionality and Ease of Use

### **1** The Data Analyzer and Analysis Toolbox

epitomizes the power and simplicity of Vision64's design. The Data Analyzer serves as a visual workflow tree, where each node either modifies the data output or performs a specific analysis. In the Analysis Toolbox, ISO-compliant filters, such as Robust Gaussian and Ball filters, combine with masking and shape removal to allow extraction of roughness, waviness or form. Comprehensive yet intuitive surface analyses make calculation of key attributes robust and accurate across a wide range of applications. Further customization and additional capabilities are provided through optional software packages, such as Optical Analysis, SureVision, and MATLAB scripting.



### **Powered by Vision64**

**The Data Visualization Window** accesses the most common plot objects with push-button convenience, from 2D and 3D analyses to bearing ratio and power spectral density displays. Customizable plots allow the operator to combine plot types and perform reporting functions, such as adding text and graphics. Data parameter tables are completely configurable and sortable in seconds.

**The Active Gallery** displays all open datasets in Vision64. Selecting a dataset from the gallery activates its Data Visualization Window and corresponding Data Analysis workflow. The tabbed measurement management feature minimizes operator confusion and time to results.

		Label Value	Units		
	- 50	Viv.p 80   Viv.p 2.9047   Vic.q 80   Vic.p 10   Vic(p.q) 59.19856	28 2 µm <sup>3</sup> /µm <sup>2</sup> % % µm <sup>3</sup> /µm <sup>2</sup>		- 100
14 A B		Vv_mr 80   Vv(mr) 2.9047   Vmp_p 10   Vmp(p) 3.52804   Vmc_q 80	% µm²/µm² % µm²/µm² %	Parto Pra	- 50
e 8000.9 1000.9	1000.0 2000.0 25000.0	Vmc,p 10   Vmc(p,q) 35.23832   Vm,mr 50   Vm(mr) 19.29373   Value: Offset 0 0	% 8 µm²/µm² % µm²/µm² %	3334	
		Skp(q) 97.5   Skp(p,q) 62.541   Skp(p) 50   Skk/Sk 0.3305	5 µm %	the second second	- 0
		5kk* 47.261 5kk 32.19 5pk/5k 2.35388 5pk/5k 0.77795 5kk* 05.50	um um	2008 ET	50
		Spk 75.77   SMr2 95.64558   SMr1 14.59029   Smr(C3) 43.84385	μm 5. 5.		



### The Measurement Parameters Window

Δ

conveniently keeps the most common measurement parameters always visible at the top right of the interface. Current measurement mode, relevant options, optics selections, and field of view size are all readily monitored and adjustable.

Measurement Type	VSI 🔻	Speed	3X	-
Objective	50 X 🔻	Backscan	150	um
Multiplier	1.0 X 👻	Length	1000	um
Measurement Area	X: 0.126 mm	Threshold	5	%
	Y: 0.094 mm	Illumination		
		🖉 Use Defaul	t	

**5 The Live Video Window** puts X, Y and Z stages, tip-tilt, and intensity controls at the operator's fingertips. Pushbutton auto intensity properly sets light level in seconds while maintaining active adjustment. This ensures measurement consistency scan after scan, even among multiple operators.



are always visible on the left side of the toolbar. Vision also utilizes custom, quick-access functionality to tailor the toolbar to your individual routines and analyses.





# Advanced Features for High Throughput Automation and Quality Control

The ContourGT 64-bit, multi-core processor and Vision64 software deliver up to 10x greater throughput and capacity than other metrology platforms, enabling rapid in-line analysis capabilities and manufacturing reliability. The ContourGT-X3 and -X8 systems incorporate both standard and customized automation features for increasing

capability and operator ease of use for a wide range of production floor applications.

Advanced Production Interface allows adaptation of ContourGT to almost any production environment and automated process. The interface provides tools to customize process workflow, automate mapping, and load measurement recipes. Software prompts and password-protected entries eliminate human error and provide robust measurement performance.

**Automation Scripting** has been designed with ease of use as the top priority. X-Y grid automation contains multiple improvements for wafer/die measurement scripting. X-Y scatter automation enables measurement on samples with nonregularly spaced areas of interest. A variety of automation routines and sample traversal patterns are available.

### Automation Ready Configuration includes

everything necessary to bring the full measurement capabilities of the ContourGT-X8 to the production floor. The system comes complete with

- Air table stabilizer kit for enhanced X,Y,Z wafer placement accuracy
- Optimization of PDU, EMO and vacuum systems for integration
- Modified system panels for autoloader integration
- Modified vacuum chucks for autoloader endeffector compatibility
- TCP/IP Run-time Control Server (V64-TCPIP-CONTROL)

### Patterned Sapphire Substrate Package

enables precise measurement and analysis of PSS structures used in the manufacture of high-brightness LEDs. This ContourGT package incorporates Bruker's proprietary PSS measurement mode, as well as a 115X objective, 2X FOV, SOA, PSS dedicated software, and a reference 2-inch PSS wafer.









# **Ten Generations of Technology Innovation**

The ContourGT Family combines decades of industry-leading design functionality with dramatic advances in measurement hardware to deliver the most accurate and repeatable optical profiling performance available. Bruker's optical surface profiling systems have a proven track record of robust performance spanning three decades, with thousands of installations in settings ranging from research labs to manufacturing fabs.

#### ■ AcuityXR<sup>™</sup> Enhanced-Resolution Microscopy

R&D 100 Award-winning AcuityXR combines patentpending hardware and software to enable ContourGT systems to break the optical diffraction limit and deliver lateral resolutions that were previously considered impossible.

### Ultra-Stable Platforms

All ContourGT profilers employ extremely stable optomechanical designs to provide the highest data quality even in difficult environments. Several models additionally contain an integrated isolation system and specialized castings to prevent the environment from reducing measurement quality. The result is fast, accurate, gage-capable metrology.

#### Industry-Leading Opto-Mechanical Design

Bruker's systems incorporate patented dual-LED illumination to provide excellent intensity and uniformity on all sample types at all magnifications. The systems deliver uncompromised accuracy and repeatability over the entire 10mm scan range. Interchangeable, fixedzoom lenses provide maximum magnification stability and resolution.

### Automatic Self-Calibration\*

Select models of the ContourGT Family include Bruker's patented automatic self-calibration capability with an internal primary standard that provides the ultimate in closed-loop scanner performance. This subsystem includes a laser interferometer that self-calibrates the system upon start-up, and then continuously monitors and corrects each measurement for absolute accuracy and superior repeatability.

### Tip-Tilt Cradle\*

Bruker's tip-tilt cradle design tilts the optics, not the sample. By doing this, the measurement sample always stays in focus and within the measurement field of view, ensuring consistent operator ease of use.



### Automated Stages

The ContourGT-X series offers standard 200-millimeter (8-inch) staging capability with an optional 300-millimeter (12-inch) stage, both with 0.5-micrometer encoders. The ContourGT bench-top systems offer the option of either 150mm (6-inch) manual or automated stages. Stages are controlled via an intuitive graphical user interface or via an available XY joystick and Z focus wheel.

#### Turret

An optional motorized turret can accommodate up to 5 interferometric objectives, from 1x to 115x. The turret design ensures that your measurement feature stays in focus and centered, even when switching objective magnifications.

#### Operator-Assist Lamp\*

The back of the vibration isolation casting is equipped with an LED light source to help with sample focus and operator visibility.

\*These options are available on the ContourGT-X Series only.

# **ContourGT Specifications**

	ContourGT-K0 Series	ContourGT-K Series	ContourGT-X Series
Form Factor	Bench top; Vibration isolation optional	Bench top; Vibration isolation optional	Integrated air table optimized for vibration isolation; Optional Ergotron® arm for keyboard and monitor
XY Sample Stages	150mm (6in) manual; ±6° manual tip-tilt in system base Optional programmable 150mm (6in) motorized	150mm (6in) manual; ±6° manual tip-tilt in system base Optional programmable 150mm (6in) motorized	200mm (8in) programmable with encoders; Optional 300mm (12in) programmable with encoders; ±6° tip-tilt in system scanning head
Z Focusing Stage	100mm manual Z axis	Motorized, computer controlled; Optional joystick controller	Motorized, computer controlled; Optional joystick controller
Optical Assembly Module	Latest generation dual-LED illumination source; Single fixed FOV	Latest generation dual-LED illumination source; Motorized FOV carousel; Automated illumination selection	Latest generation dual-LED illumination source; Motorized FOV carousel; Automated illumination selection
Objectives	Parfocal: 2.5x, 5x, 10x, 20x, 50x; LWD: 2x, 5x, 10x	Parfocal: 2.5x, 5x, 10x, 20x, 50x, 115x; LWD: 1x, 1.5x, 2x, 5x, 10x; Through Transmissive Media: 2x, 5x, 10x, 20x	Parfocal: 2.5x, 5x, 10x, 20x, 50x, 115x; LWD: 1x, 1.5x, 2x, 5x, 10x; Through Transmissive Media: 2x, 5x, 10x, 20x
Objective Mounts	Single objective adapter or 4-position manual turret	Single objective adapter or 4- or 5-position motorized turret	Single objective adapter or 4- or 5-position motorized turret
Processor	Multi-core, Windows® 7.0	Multi-core, Windows® 7.0	Multi-core, Windows® 7.0
System Software	Vision64 Operation and Analysis Software	Vision64 Operation and Analysis Software	Vision64 Operation and Analysis Software
Optional Software Analysis	Production Interface	AcuityXR, Production Interface, MATLAB®, SureVision, TCP/IP Control, ThickFilm, Annular, Optical	AcuityXR, Production Interface, MATLAB®, SureVision, TCP/IP Control, ThickFilm, Annular, Optical
Other Automation	Auto intensity; Camera autofocus	Auto intensity; Camera autofocus; Optional high-speed autofocus; Optional stitching; Optional X-Y automation	Auto intensity; Camera autofocus; X-Y automation; Optional high-speed autofocus; Optional stitching
Calibration	Via traceable step standards	Via traceable step standards	Via traceable step standards; X8: automatic, continuous calibration via internal laser standard
Z Scan Range	0.1nm to 10mm	0.1nm to 10mm	0.1nm to 10mm
Max. Scan Speed	28.1µm/sec	28.1µm/sec	X3: 28.1µm/sec; X8: 92.5µm/sec
Max. Sample Weight	4.5kg (10lbs)	4.5kg (10lbs)	45kg (100lbs)
Warranty	18 months parts and labor	18 months parts and labor	18 months parts and labor

Note: Performance specifications are typical and subject to change without notice.

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products and reserves the right to change specifications without

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#### **Cover Images:**

their respective companies.

Foreground: ContourGT 3D Optical Microscopes. Background: (left) 3D optical surface profile of HB-LED PSS features and (right) cam chatter.

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